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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application: Sang Tae AHN et al.

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Serial No: 10/738,399

] Ex.:

Filed: December 17, 2003

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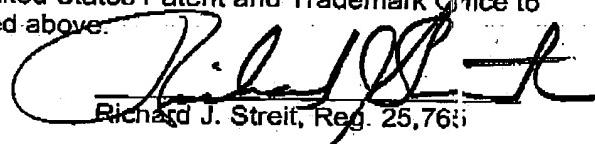
For: METHOD FOR FABRICATING ISOLATION LAYER IN SEMICONDUCTOR DEVICE

Certification under 37 C.F.R. §1.8(a)

The USPTO Central Fax No. (703) 872-9306

Date of Fax Transmittal: May 21, 2004

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted to the United States Patent and Trademark Office to the fax number and on the date indicated above.



Richard J. Streit, Reg. 25,765

The Commissioner for Patents  
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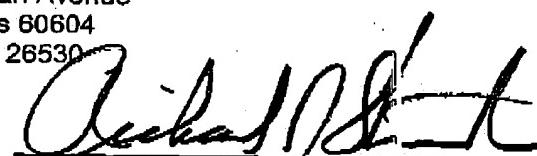
APPOINTMENT OF ASSOCIATE ATTORNEY

Dear Sir:

The undersigned Attorney for Applicants in the above identified application for Letters Patent, hereby appoints Wochoon William Park, Reg. No. 55,523 as my Associate Attorney, to prosecute this application, to make alterations and amendments therein, to receive the patent, and to transact all business in the United States Patent & Trademark Office connected therewith.

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Dated: May 21, 2004


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